



AO-001-2D

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Vlad J. Novotny

Assignee: Active Optical Networks, Inc.

Title: "DEEP-WELL LITHOGRAPHY PROCESS FOR FORMING
MICRO-ELECTRO-MECHANICAL STRUCTURES"

Serial No.: 10/027,882 Filing Date: 12/21/01

Examiner: Ahmed, Shamim Art Unit: 1765

Docket No.: AO-001-2D

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN RESPONSE TO FIRST OFFICE ACTION

Sir:

In response to the Office Action dated July 21, 2003,
please amend the above-identified application as follows:

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TC 1700